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Sheet 1 of 1

LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

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| Atty Docket No. | Serial No. |
| A01072 | 09/943,690 |
| Applicant | |
| Jane Elizabeth Weier et al. | |
| Filing Date | Group |
| August 31, 2001 | 1714 |

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| | BC | |
| | BD | |
| Examiner | Date Considered | |
| Tae Yoon | 1-26-04 | |

*EXAMINER: Initial reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.

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